

Docket: 740819-640

Jc978 U.S. PRO  
09/942907  
08/31/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of ) *E. Willis*  
Tsuneo IKURA ) 12-3-01  
Japanese Priority Application No. 2000-362300 ) Attn: Applications  
Japanese Priority Date: November 29, 2000 ) Branch  
For: METHOD FOR FABRICATING )  
SEMICONDUCTOR DEVICE ) Date: August 31, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

  
Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110